



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*In re* Patent Application of:

Woon-Yong PARK, *et. Al.*

Serial No.: 10/627,752

Confirmation No.: 4396

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Docket No.: 6192.0091.D2

Group Art Unit: 1756

Examiner: TBA

For: **PHOTOLITHOGRAPHY METHOD FOR THIN FILM ( AS AMENDED)**

Mail Stop: Missing Parts  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NOTICE TO FILE CORRECTED APPLICATION PAPERS**

Sir:

In response to the Notice to File Corrected Application Papers mailed November 4, 2003, Applicants respectfully files the following Amendments and Remarks.

Applicants believe that no extensions of time are required at this time. If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned for under 37 C.F.R. §1.136(a). Applicants believe that no further fees for net addition of claims are required at this time. Any fees required for further extensions of time and any fees for the net addition of claims are hereby authorized to be charged to our Deposit Account No. 23-1951.